SPEC Macros for REIXS Beamline

Elliptically polarized undulator (EPU) macros

setEPU epu_comp value [angle]

Options for *epu_comp*: *polar*, *harmo*, or *offset value* for *polar*: *cl*, *cr*, *lh*, *lvp*, *lvn*, or *li* — for circular left, circular right, linear horizontal, linear vertical +, linear vertical –, or linear inclined angle with [*angle*] is between –90 to +90 (degrees). Circular polarization is available for the **first** harmonic only. *value* for *harmo*: 1, 3, or 5 *value* for *offset* in mm

Monochromator macros

• moveE energy — moves to the specified energy in eV

Options for *energy*: 300 – 3000 eV — for Au HEG 95 – 800 eV — for Ni LEG 95 – 250 eV — for Au LEG

- moveG grating moves grating with options of AuHEG, NiLEG, or AuLEG
- moveM mirror moves mirror with options of Nickel, Silicon, Gold, or Carbon
- setE energy_in_eV used for setting user energy at the current monochromator position

Beam status macros

- setBEAM state ensures availability of beam with state options of on or off
- chkBEAM parameter [state]

Options for *parameter*: *ring*, *psh*, or *vvr* with [*state*] of *on* or *off* — checks ring state and safety shutters, state of photon shutters, or state of gate valves *on* or *off* — turns all above parameters on or off *status* — displays status of checking

Beamline components (apertures, diagnostic stages, 4jaws, exit slit) macros

• **setBL** *bl_comp* value

Options for *bl_comp*: *vahgap*, *vavgap*, *esgap*, *bds3*, or *bds4 value* for *vah* and *vav* in mm — variable aperture horizontal and vertical gap in mm *value* for *bds3*: *out*, *yag*, or *au* — beam diagnostic stage 3 (out, YAG, or Gold mesh)

- getBL bl_comp options for bl_comp: vah, vav, or bds3
- setES value value in um for Exit slit vertical gap

Photon shutters and gate valve macros

- setPSH state open or close beamline shutter with state options of on or off
- statPSH displays state of photon shutter
- setVVR state open or close endstation gate valve with state options of on or off
- statVVR displays state of endstation gate valve

Current amplifiers macros

- **setAMP** *mne value* with *mne* = *tey* or *i0* and sensitivity *value* options is either *up* or *down* for relative change or exact value for example 1pA/V or 2nA/V.
 - <u>Notes:</u> The exhaustive list of sensitivity are 1, 2, and 5 with a range of 1 mA/V to 1pA/V and all orders of magnitude in between.
- **statAMP** displays the current sensitivity of both amplifiers

Special scanning macros

• Escan start1 end1 intervals1 [end2 intervals2 ...] time [fixQ]

<u>Notes:</u> Escan works for single and multiple region energy scan with and without [fixQ]. For fixQ energy scan (only available for FOURC), it is better to scan from high to low energy.

- **elmesh** *Estart Efinish intervals_1 Lstart Lfinish intervals_2 time* Energy L mesh (only FOURC)
- **ehmesh** *Estart Efinish intervals_1 Hstart Hfinish intervals_2 time* Energy H mesh (only FOURC)
- **Tscan** *time_interval total_time*

RSXS detector filters and slits selection

• slitselect slit_number detector_name

Option for *slit_number*: 1 to 10 with *detector_name* of either *cht* (for channeltron) or *pd* (for photodiode).

Silicon drift detector (SDD) multi channel analyzer (MCA) and region of interest (ROI) macros

- setSDD state acquiring or not acquiring SDD MCA with state options of on or off
- setSDD roi roi_num low_energy high_energy acquiring SDD ROI SCA with roi_num of 1, 2, or 3 and the energy range from low_energy to high_energy

Microchannel plate (MCP) 2D image and region of interest (ROI) macros

- setMCP state acquiring or not acquiring MCP 2D image with state options of on or off
- **setMCP** roi roi_num tth1p tth2p detz1p detz2p with roi_num of 1 or 2 and the two-theta range in pixel from tth1p to tth2p and the detector height range in pixel from detz1p to detz2p